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NOTICE OF ALLOWANCE AND FEE(S) DUE

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P.O. BOX 1687

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Beyer Law Group LLP

Cupertino, CA 95015-1687

07/25/2008

EXAMINER

ARANCIBIA, MAUREEN GRAMAGLIA

ART UNIT

PAPER NUMBER

1792

DATE MAILED: 07/25/2008

APPLICATION NO. FILING DATE		FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
	10/600,191	06/20/2003	Douglas L. Keil	LAM1P175	8804

TITLE OF INVENTION: MAGNETIC ENHANCEMENT FOR MECHANICAL CONFINEMENT OF PLASMA

APPLN. TYPE	SMALL ENTITY	ISSUE FEE DUE	PUBLICATION FEE DUE	PREV. PAID ISSUE FEE	TOTAL FEE(S) DUE	DATE DUE
nonprovisional	NO	\$1440	\$300	\$0	\$1740	10/27/2008

THE APPLICATION IDENTIFIED ABOVE HAS BEEN EXAMINED AND IS ALLOWED FOR ISSUANCE AS A PATENT. PROSECUTION ON THE MERITS IS CLOSED. THIS NOTICE OF ALLOWANCE IS NOT A GRANT OF PATENT RIGHTS. THIS APPLICATION IS SUBJECT TO WITHDRAWAL FROM ISSUE AT THE INITIATIVE OF THE OFFICE OR UPON PETITION BY THE APPLICANT. SEE 37 CFR 1.313 AND MPEP 1308.

THE ISSUE FEE AND PUBLICATION FEE (IF REQUIRED) MUST BE PAID WITHIN THREE MONTHS FROM THE MAILING DATE OF THIS NOTICE OR THIS APPLICATION SHALL BE REGARDED AS ABANDONED. THIS STATUTORY PERIOD CANNOT BE EXTENDED. SEE 35 U.S.C. 151. THE ISSUE FEE DUE INDICATED ABOVE DOES NOT REFLECT A CREDIT FOR ANY PREVIOUSLY PAID ISSUE FEE IN THIS APPLICATION. IF AN ISSUE FEE HAS PREVIOUSLY BEEN PAID IN THIS APPLICATION (AS SHOWN ABOVE), THE RETURN OF PART B OF THIS FORM WILL BE CONSIDERED A REQUEST TO REAPPLY THE PREVIOUSLY PAID ISSUE FEE TOWARD THE ISSUE FEE NOW DUE.

HOW TO REPLY TO THIS NOTICE:

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III. All communications regarding this application must give the application number. Please direct all communications prior to issuance to Mail Stop ISSUE FEE unless advised to the contrary.

IMPORTANT REMINDER: Utility patents issuing on applications filed on or after Dec. 12, 1980 may require payment of maintenance fees. It is patentee's responsibility to ensure timely payment of maintenance fees when due.

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Complete and send this form, together with applicable fee(s), to: Mail Mail Stop ISSUE FEE

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10/600,191	06/20/2003		Douglas L. Keil			LAM1P175	5	8804
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3. ASSIGNEE NAME A	ND RESIDENCE DATA	A TO BE PRINTED ON	LTHE PATENT (print or	r type	e)			
PLEASE NOTE: Unl	ess an assignee is ident	ified below, no assignee	data will appear on th	e pa	tent. If an assigne	e is identified bel	ow, the do	ocument has been filed for
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Please check the appropr	iate assignee category or	categories (will not be p	rinted on the patent):		Individual 🖵 Co.	rporation or other p	orivate gro	up entity 📮 Government
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Advance Order -	Advance Order - # of Copies		The Director is hereby authorized to charge the required fee(s), any deficiency, or credit any overpayment, to Deposit Account Number (enclose an extra copy of this form).					
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10/600,191 06/20/2003		2003	Douglas L. Keil	LAM1P175	8804		
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P.O. BOX 1687	P.O. BOX 1687		ART UNIT PAPER NUMBER				
Cupertino, CA 95015-1687				1792			
				DATE MAILED: 07/25/200	8		

Determination of Patent Term Adjustment under 35 U.S.C. 154 (b)

(application filed on or after May 29, 2000)

The Patent Term Adjustment to date is 532 day(s). If the issue fee is paid on the date that is three months after the mailing date of this notice and the patent issues on the Tuesday before the date that is 28 weeks (six and a half months) after the mailing date of this notice, the Patent Term Adjustment will be 532 day(s).

If a Continued Prosecution Application (CPA) was filed in the above-identified application, the filing date that determines Patent Term Adjustment is the filing date of the most recent CPA.

Applicant will be able to obtain more detailed information by accessing the Patent Application Information Retrieval (PAIR) WEB site (http://pair.uspto.gov).

Any questions regarding the Patent Term Extension or Adjustment determination should be directed to the Office of Patent Legal Administration at (571)-272-7702. Questions relating to issue and publication fee payments should be directed to the Customer Service Center of the Office of Patent Publication at 1-(888)-786-0101 or (571)-272-4200.

	Application No.	Applicant(s)
	10/600,191	KEIL ET AL.
Notice of Allowability	Examiner	Art Unit
	Maureen G. Arancibia	1792
	Maureen G. Arancibia	1792
The MAILING DATE of this communication app All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85 NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT R of the Office or upon petition by the applicant. See 37 CFR 1.313	6 (OR REMAINS) CLOSED in this ap) or other appropriate communication RIGHTS. This application is subject t	plication. If not included n will be mailed in due course. THIS
1. \boxtimes This communication is responsive to <u>the reply filed 28 Apr</u>	r <u>il 2008</u> .	
2. X The allowed claim(s) is/are 2,3,5-10 and 18-26.		
 Acknowledgment is made of a claim for foreign priority u a) ☐ All b) ☐ Some* c) ☐ None of the: 	nder 35 U.S.C. § 119(a)-(d) or (f).	
 Certified copies of the priority documents have 	e been received.	
Certified copies of the priority documents have	e been received in Application No	
Copies of the certified copies of the priority do	ocuments have been received in this	national stage application from the
International Bureau (PCT Rule 17.2(a)).		
* Certified copies not received:		
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONN THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		complying with the requirements
 A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which giv 		
5. CORRECTED DRAWINGS (as "replacement sheets") mu	st be submitted.	
(a) ☐ including changes required by the Notice of Draftsper	son's Patent Drawing Review (PTO	-948) attached
1) 🔲 hereto or 2) 🔲 to Paper No./Mail Date	_	
(b) ☐ including changes required by the attached Examiner	's Amendment / Comment or in the 0	Office action of
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Identifying indicia such as the application number (see 37 CFR 1 each sheet. Replacement sheet(s) should be labeled as such in t		
 DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT 		
Attachment(s)		
1. Notice of References Cited (PTO-892)	5. Notice of Informal F	• •
2. Notice of Draftperson's Patent Drawing Review (PTO-948)	6. ☐ Interview Summary Paper No./Mail Da	te
 Information Disclosure Statements (PTO/SB/08), Paper No./Mail Date 	7. 🛛 Examiner's Amend	ment/Comment
4. Examiner's Comment Regarding Requirement for Deposit of Biological Material		ent of Reasons for Allowance
	9.	

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EXAMINER'S AMENDMENT

1. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

- 2. Authorization for this examiner's amendment was given in a telephone interview with Masako Ando on 16 July 2008.
- 3. The application has been amended as follows:

Cancel Claims 10-14.

Replace the text of Claim 2 as follows:

A plasma processing apparatus for processing a substrate, comprising:

a plasma processing chamber with chamber walls;

a substrate support within the chamber walls;

a plurality of confinement rings spaced apart from each other, and within and spaced apart from the chamber walls, wherein the confinement rings and the substrate support define a plasma volume; and

a magnetic source for generating a magnetic field for magnetically enhancing physical confinement provided by the <u>confinement rings</u>, the magnetic field having a <u>strength to bend a trajectory of a particle passing through the magnetic field but</u> not having a strength to magnetically confine a plasma,

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wherein the magnetic source comprises a first magnetic element spaced apart from and placed on a first side of the <u>confinement rings</u>, so that the first magnetic element is closer to the substrate support than the <u>confinement rings</u>, and a second magnetic element spaced apart from and placed on a second side of the <u>confinement rings</u>, so that the second magnetic element is farther from the substrate support than the <u>confinement rings</u>, wherein magnetic field lines passing from the first magnetic element to the second magnetic element pass through the confinement rings.

Replace the text of Claim 3 as follows:

3. The plasma processing apparatus, as recited in claim 2, wherein the magnetic source is configured such that the magnetic field passing through the confinement rings increases collisions of charged particles with the confinement rings.

Replace the text of Claim 5 as follows:

5. The plasma processing apparatus, as recited in claim 3, wherein the first magnetic element forms a ring shape with a diameter and the second magnetic element forms a ring shape with a diameter, and wherein the <u>confinement rings</u> have an inner diameter and an outer diameter, wherein the diameters of the first magnetic element and the second magnetic element are less than the outer diameter of the <u>confinement rings</u> and greater than the inner diameter of the <u>confinement rings</u>.

Replace the text of Claim 7 as follows:

7. The plasma processing apparatus, as recited in claim 2, wherein the magnetic fields pass through the region of the <u>confinement rings</u>.

Replace the text of Claim 8 as follows:

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8. The plasma processing apparatus, as recited in claim 7, wherein the first magnetic element forms a ring shape with a diameter and the second magnetic element forms a ring shape with a diameter, and wherein the <u>confinement rings</u> have an inner diameter and an outer diameter, wherein the diameters of the first magnetic element and the second magnetic element are less than the inner diameter of the confinement rings.

Replace the text of Claim 9 as follows:

9. The plasma processing apparatus, as recited in claim 2, wherein the confinement rings are movable to define a variable gap, wherein the variable gap is used to vary pressure in the plasma volume.

Replace the text of Claim 19 as follows:

19. The plasma processing apparatus, as recited in claim 2, wherein <u>each of the confinement rings</u> has sides that form largest surfaces of the confinement ring wherein the magnetic field lines passing from the first magnetic element to the second magnetic element pass through the sides of the <u>confinement rings</u> that form largest surfaces of the <u>confinement rings</u> at an angle between being perpendicular to 45° with the sides of the <u>confinement rings</u> that form largest surfaces of the <u>confinement rings</u>.

Replace the text of Claim 20 as follows:

20. The plasma processing apparatus, as recited in claim 2, wherein the confinement rings, comprises a first confinement ring and a second confinement ring spaced from the first confinement ring, wherein the first magnetic element is placed on a first side of the first confinement ring and second confinement ring and is closer to the

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first confinement ring than to the second confinement ring and the second magnetic element is placed on a second side of the first confinement ring and second confinement ring and is closer to the second confinement ring than to the first confinement ring, and wherein magnetic field lines passing from the first magnetic element to the second magnetic element pass through the first confinement ring and the second confinement ring.

Replace the text of Claim 22 as follows:

22. The plasma processing apparatus, as recited in claim 21, wherein <u>each of</u> the confinement rings has sides that form largest surfaces of the confinement ring wherein the magnetic field lines passing from the first magnetic element to the second magnetic element pass through the sides of the <u>confinement rings</u> that form largest surfaces of the <u>confinement rings</u> at an angle between being perpendicular to 45° with the sides of the confinement rings that form largest surfaces of the confinement rings.

Replace the text of Claim 24 as follows:

24. The plasma processing apparatus, as recited in claim 2, wherein the first magnetic element is arranged in a ring shape having a first diameter and the second magnetic element is arranged in a ring shape having a second diameter different from the first diameter, and wherein the magnetic field lines passing from the first magnetic element to the second magnetic element pass through the <u>confinement rings</u> in a canted manner.

Replace the text of Claim 26 as follows:

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26. The plasma processing apparatus, as recited in claim 2, wherein the first magnetic element is provided near the inner edge of the <u>confinement rings</u>, and the second magnetic element is provided near the outer edge of the <u>confinement rings</u>.

Reasons for Allowance

4. Claims 2, 3, 5-10, and 18-26 are allowed.

The following is an examiner's statement of reasons for allowance: the prior art of record, whether alone or in combination, fails to teach or fairly suggest, in the context of Claim 2, a plasma processing apparatus comprising a plurality of confinement rings spaced apart from each other and within and spaced apart from the chamber walls; and a magnetic source for generating a magnetic field for magnetically enhancing physical confinement provided by the confinement rings, the magnetic field having a strength to bend a trajectory of a particle passing through the magnetic field but not having a strength to magnetically confine a plasma; the magnetic source comprising first and second magnetic elements provided as recited in Claim 2 such that magnetic field lines passing from the first magnetic element to the second magnetic element pass through the confinement rings.

5. Applicant's arguments (see pages 8-9 of the Remarks filed 28 April 2008) against the combination of Imafuku and Lenz in regards to Claim 2 as amended were persuasive, specifically that Imafuku only teaches a magnetic source generating a magnetic field that is by itself strong enough to magnetically confine the plasma, and that there is no teaching or suggestion in the prior art of record to additionally provide the confinement rings of Lenz in the apparatus of Imafuku while also modifying the

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strength of the magnetic field of Imafuku to be strong enough to bend a trajectory of a particle passing through the magnetic field but not strong enough to magnetically confine the plasma.

6. Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Conclusion

7. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Maureen G. Arancibia whose telephone number is (571)272-1219. The examiner can normally be reached on core hours of 10-5, Monday-Friday.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Parviz Hassanzadeh can be reached on (571) 272-1435. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

/Maureen G. Arancibia/ Examiner, Art Unit 1792

/Parviz Hassanzadeh/ Supervisory Patent Examiner, Art Unit 1792